

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Marco Wedowski et al. Art Unit : 2837
Serial No. : 10/598,481 Examiner : Unknown
Filed : June 18, 2007 Conf. No. : 5997
Title : METHODS FOR MANUFACTURING REFLECTIVE OPTICAL ELEMENTS, REFLECTIVE OPTICAL ELEMENTS, EUV-LITHOGRAPHY APPARATUSES AND METHODS FOR OPERATING OPTICAL ELEMENTS AND EUV-LITHOGRAPHY APPARATUSES, METHODS FOR DETERMINING THE PHASE SHIFT, METHODS FOR DETERMINING THE LAYER THICKNESS, AND APPARATUSES FOR CARRYING OUT THE METHODS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Please correct the Filing Receipt for the above-referenced application as follows.

Please correct the title to read as:

--METHODS FOR MANUFACTURING REFLECTIVE OPTICAL ELEMENTS, REFLECTIVE OPTICAL ELEMENTS, EUV-LITHOGRAPHY APPARATUSES AND METHODS FOR OPERATING OPTICAL ELEMENTS AND EUV-LITHOGRAPHY APPARATUSES, METHODS FOR DETERMINING THE PHASE SHIFT, METHODS FOR DETERMINING THE LAYER THICKNESS, AND APPARATUSES FOR CARRYING OUT THE METHODS--

Please correct the Domestic priority data to read as:

--This application is a 371 of PCT/EP05/50985 03/04/2005
which claims the benefit of 60/550,302 03/05/2004--

Please supply a corrected Filing Receipt to the undersigned with respect to this application. A copy of the original Filing Receipt showing the desired changes in red ink is attached for your convenience.

CERTIFICATE OF MAILING BY EFS-WEB FILING

I hereby certify that this paper was filed with the Patent and Trademark Office using the EFS-WEB system on this date: September 11, 2007

Applicant : Marco Wedowski et al.
Serial No. : 10/598,481
Filed : June 18, 2007
Page : 2 of 2

Attorney's Docket No.: 17979-046US1 / 05028 P WO
US

No fee is believed to be due. If, however, there are any charges or credits, please apply them to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 11, 2007

/Sean P. Daley/

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APPL NO.	FILING OR 371(C) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	TOT CLMS	IND CLMS
10/598,481	06/18/2007	2837	1130	17979-046US1	22	3

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CONFIRMATION NO. 5997
FILING RECEIPT

 OC000000025662102

Date Mailed: 09/07/2007

Receipt is acknowledged of this nonprovisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

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Assignment For Published Patent Application

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Domestic Priority data as claimed by applicant

This application is a 371 of PCT/EP05/50985 03/04/2005
 which claims benefit of 60/550,302 03/05/2004

Foreign Applications

GERMANY 10 2004 011 356.4 03/05/2004
 GERMANY 10 2004 011 355.6 03/05/2004

If Required, Foreign Filing License Granted: 09/01/2007

The country code and number of your priority application, to be used for filing abroad under the Paris

Convention, is **US10/598,481**

Projected Publication Date: 12/13/2007

Non-Publication Request: No

Early Publication Request: No

Title

Apparatuses

Method For Manufacturing Reflective Optical Element, Reflective Optical Elements, Euv-Lithography Apparatus, And Methods For Operating Optical Elements And Euv-Lithography Apparatuses Apparatus, Methods For Determining The Phase Shift, Methods For Determining The Layer Thickness, And Apparatuses For Carrying Out The Methods

Preliminary Class

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Title 37, Code of Federal Regulations, 5.11 & 5.15**GRANTED**

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